



Docket No.: SON-1718  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:

Yasukiyasu Sugano et al.

Application No.: 09/478,812

**Confirmation No.: 2204**

Filed: January 7, 2000

Art Unit: 2815

For: PROCESS FOR PRODUCING THIN FILM  
SEMICONDUCTOR DEVICE AND LASER  
IRRADIATION APPARATUS

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Examiner: Eugene Lee

**AMENDMENT**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the non-final Office Action dated February 15, 2006, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 12 of this paper.